

**INFORMATION DISCLOSURE CITATION**  
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Docket Number (optional)  
**YOU102**

Application No.  
**10/786,379**

Applicants(s)  
**Kim et al.**

Filing Date  
**February 25, 2004**

Group Art Unit  
**1762**

**U.S. PATENT DOCUMENTS**

*Examiner Initial	REF	DOCUMENT NUMBER	DATE	NAME	CLASS/SUBCLASS	FILING DATE IF APPROPRIATE
<i>ECC</i>		5,108,793	04/28/1992	van Ooij et al.	427/327	
<i>Ecc</i>		5,200,275	04/06/1993	van Ooij et al.	428/623	
<i>Ecc</i>		5,292,549	03/08/1994	van Ooij et al.	427/156	
<i>Ecc</i>		5,433,976	07/18/1995	van Ooij et al.	427/327	
<i>Ecc</i>		5,487,792	01/30/1996	King et al.	136/256	
<i>Ecc</i>		5,750,197	05/12/1998	van Ooij et al.	427/318	
<i>Ecc</i>		5,759,629	06/02/1998	van Ooij et al.	427/384	
<i>Ecc</i>		6,102,521	08/15/2000	Halko et al.	347/47	
<i>Ecc</i>		6,183,815 B1	02/06/2001	Enick et al.	427/400	
<i>Ecc</i>		6,461,682 B1	10/08/2002	Crotty et al.	427/387	

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/SUBCLASS	TRANSLATION	
						YES	NO
<i>Ecc</i>		WO 02/072283 A1	09/19/2002	PCT	<del>B05D/3/02</del>		

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

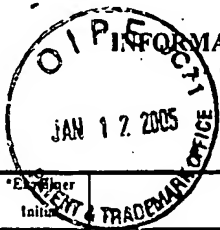

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